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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Akira IZUMI

Date: November 11, 2003

Serial No.: 10/634,432

Group Art Unit: 1763

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Examiner: Not Yet Assigned

For: **SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING
METHOD DRYING SUBSTRATE BY SPRAYING GAS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

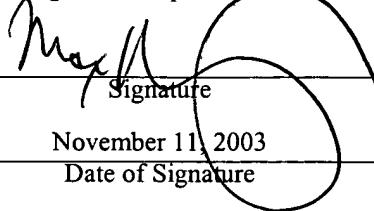
Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on November 11, 2003

Max Moskowitz

Respectfully submitted,

Name of applicant, assignee or
Registered Representative


Signature

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